## **PATENT APPLICATION**

## RESPONSE UNDER 37 CFR §1.116 EXPEDITED PROCEDURE TECHNOLOGY CENTER ART UNIT 2828

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of DO NOT ENTER: /SH/

Daniel KOPF et al. Group Art Unit: 2828

Application No.: 10/581,893 Examiner: S. HAGAN

Filed: September 29, 2006 Docket No.: 120391

For: HIGH-REPETITION LASER SYSTEM FOR GENERATING ULTRA-SHORT

PULSES ACCORDING TO THE PRINCIPLE OF PULSE DECOUPLING

## **AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the April 27, 2009 Office Action and in consideration of the July 22, 2009 personal interview, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and Remarks.